

INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

December 2, 2024

IGI Report Number

Description

Shape and Cutting Style

Measurements

LG667438398

LABORATORY GROWN DIAMOND

EMERALD CUT

10.40 X 7.71 X 5.22 MM

GRADING RESULTS

Carat Weight

Color Grade

Clarity Grade

4.04 CARATS

H

SI 1

ADDITIONAL GRADING INFORMATION

Polish

Symmetry

Fluorescence


EXCELLENT

EXCELLENT

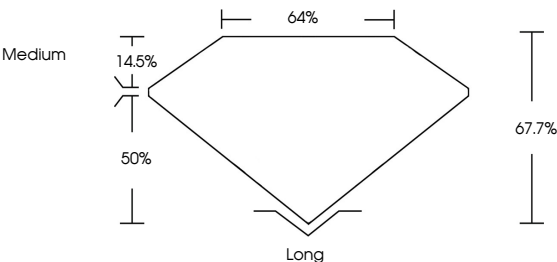
NONE

Inscription(s)

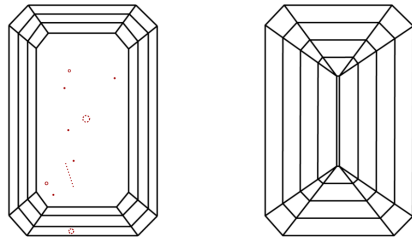
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

 LG667438398

PROPORTIONS



CLARITY CHARACTERISTICS




KEY TO SYMBOLS

Red symbols indicate internal characteristics.

Green symbols indicate external characteristics.

Sample Image Used



COLOR



D E F G H I J

Faint Very Light Light

CLARITY

IF VS 1-2 VS 1-2 SI 1-2 I 1-3


Internally Flawless Very Very Slightly Included Very Slightly Included Slightly Included Included



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
EXCELLENT

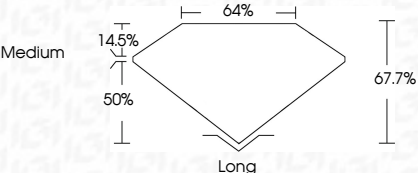
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EMERALD CUT

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Carat Weight

Color Grade

Clarity Grade

Depth

Table

Girdle

4.04 CARATS

H

SI 1

67.7%

64%


Medium

Long

EXCELLENT

EXCELLENT

NONE

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Culet

Polish

Symmetry

Fluorescence

Inscription(s)

NONE

EXCELLENT

EXCELLENT

NONE

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